Electronic Patent Application Fee Transmittal						
Application Number:	10658460					
Filing Date:	10-Sep-2003					
Title of Invention:	Bias sputtering film forming process and bias sputtering film forming apparatus					
First Named Inventor/Applicant Name:	Myounggoo Lee					
Filer:	Tarik Nabi/Wendy Barrow					
Attorney Docket Number:	029567-00004					
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Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)	
Basic Filing:	-					
Pages:						
Claims:						
Miscellaneous-Filing:						
Petition:						
Patent-Appeals-and-Interference:						
Post-Allowance-and-Post-Issuance:						
Extension-of-Time:						
Extension - 3 months with \$0 paid		1253	1	1110	1110	

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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